		<u>.</u>				, Shee	et <u>1 of 1</u>	
	Form PTO 1	449	U.S. Dep	of Commerce	Atty. Docket No.	Serial No.		
	Rev 7-80		Patent &	Trademark Off.	UK9-93-044	08/364,334		g de la companya de
	INFORMATION DISCLOSURE CITATION				Applicant	_		
					ODED COHN ET A		PEOE	VE
	W. III	AND APP	LICATION		Filing Date 12/27/94	Group 27	159 / 1100	A T.
1		20			12/21/34	2010 /	159 (UEU 17	1776
1	9.	4.		U.S. PATENT	DOCUMENTS		GPOUP	•
/1	EXAMINER,					CLASS/ /		230
	INDPLAT	NUM	BER	DATE	NAME	SUBCLASS	FILING DATE	
				FOREIGN PA	TENT DOCUMENTS			
	EXAMINER		JMENT			CLASS/		
	INITIAL	NUM	BER	DATE	NAME	SÚBCLASS	FILING DATE	
AA		JP02	-205913	8/15/90	TSUKADA	<u>/</u>	2/3/89	
ΑB		JP62	-256025	11/7/87	KUROKAWA /		4/28/86	
AC		JP60	-55421	3/30/85	KITANI	-	9/6/83	
AD		JP58	-105365	6/23/83	KANEKO /		12/18/81	
	EXAMINER		Р	UBLICATIONS O	R OTHER INFORMAT	FION		
	<u>INITIAL</u>		(INCLUDE	AUTHOR, TITLE	<u>, DATE, PERTINENT</u>	PAGE, ETC)		
					. /			
	Hitachi Review, "High Performance Auxiliary Storages and Their Total System							
	Evaluation Method" Akira Yamamoto, Toru Nishigaki, Hiroyuki Kitajima, Akira Kurano, Toskhihiko Tamiya,							
	8/1984, pgs	s. 23-27	7	/	/			
					·			
	EXAMINER Prep 7 Mayor				DAT	E CONSIDEREI)	
		ine thro	ugh citation	if not/in conform	nether or not citation ance and not conside			
						-		
	•			/				
			/	/				
			/					